

**Dynamic risk assessment of chemical process systems using the System-Theoretic accident model and process approach (STAMP) in combination with cascading failure propagation model (CFPM)**

Sun H, Wang H, Yang M, Reniers G.

Safety science

2024; 171:e106375

**ARTICLE IDENTIFIERS**

DOI: 10.1016/j.ssci.2023.106375

PMID: unavailable

PMCID: not available

**JOURNAL IDENTIFIERS**

LCCN: 91640944

pISSN: 0925-7535

eISSN: 1879-1042

OCLC ID: 23966897

CONS ID: sn 91-38208

US National Library of Medicine ID: 9114980

This article was identified from a query of the SafetyLit database.